

10/659,778

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I hereby certify that this paper and fee are being TRANSMITTED VIA FACSIMILE TO: Assistant Commissioner for Patents, P. O. Box 1450, ALEXANDRIA, VA 22313-1450. Date of Deposit: 12/15/04 Name of Person Making Deposit: Linda Roberts-Jackson

Signature

In the United States Patent and Trademark Office

Date:	12/15/04		
In re Application	Edward Barth, et al.	Filed:	9/10/03
of:			
For:	Dual-Damascene Interconnect Structure Using Low Stress Fluorosilicate Insulator with Copper Conductors		
Serial Number:	10/659,778	Confirmation No.	5616
Art Unit:	2822	Examiner:	Novacek, Christy L.

AMENDMENT

Hon. Commissioner of Patents and Trademarks
P. O. Box 1450
Alexandria, VA 23313-1450

Dear Sir:

In response to the Final Office Action dated October 15, 2004, Applicants submit
the following amendments and remarks: